

## Role of strain in interacting silicon nanoclusters

Roberto Guerra and Stefano Ossicini

*Dipartimento di Scienze e Metodi dell'Ingegneria and Centro Interdipartimentale En&Tech, Università di Modena e Reggio Emilia, via Amendola 2 Pad. Morselli, I-42122 Reggio Emilia, Italy*

(Received 1 February 2013; published 29 April 2013)

The possibility of controlling the optical transition probability between neighboring silicon nanoclusters (Si-NCs) constitutes nowadays an attractive prospect in nanophotonics and photovoltaics. In this work, by means of theoretical *ab initio* calculations, we investigate the effect of strain on the optoelectronic properties of Si-NCs pairs. We consider two sources of strain: the strain induced by an embedding SiO<sub>2</sub> matrix and the strain generated by mutual NC-NC forces occurring at small distances. Independently on its source, we observe a fundamental impact of the strain on the orbital localization and, as a consequence, on the transition probability between energy states belonging or not to the same NC. The resulting picture allots to the structural strain a fundamental role in the NC-NC interaction mechanisms, suggesting the possibility of enabling a strain-controlled response in Si-NC ensembles.

DOI: [10.1103/PhysRevB.87.165441](https://doi.org/10.1103/PhysRevB.87.165441)

PACS number(s): 78.67.Bf, 73.22.-f, 61.46.Df

### I. INTRODUCTION

Highly promising results have been obtained in the latest years from Si nanoclusters (NCs) in many fields, among which photonics,<sup>1,2</sup> nonvolatile memories,<sup>3,4</sup> and biological applications,<sup>5</sup> while trial photovoltaic devices are under investigation.<sup>6</sup> In all the cases, the main advantage of this system comes from the chance of tuning the optical response by changing the NC size and other structural characteristics. In addition, evidence of an interaction mechanism operating between NCs has been frequently reported,<sup>7-9</sup> sometimes indicated as an active process for optical emission,<sup>10</sup> and sometimes even exploited as a probing technique.<sup>11</sup> Moreover, a mechanism based on the transformation of high-energy photons into low-energy electron-hole pairs, via multiple exciton generation (MEG), localized on neighboring Si nanocrystals has been proposed<sup>12,13</sup> and elucidated<sup>14</sup> as a suitable route to minimize solar cell loss factors.

Nevertheless, while the role of the size, shape, interface configuration, and embedding medium on the optoelectronic properties of single NCs has been extensively investigated,<sup>15-19</sup> the study of the effects of NC-NC interplay has received less attention. In the simplest picture, when the separation between the NCs lowers under a certain limit, the wave functions overlap with the neighbor ones, promoting the tunneling process and limiting the quantum-confinement (QC) effect.

From the experimental point of view, it is difficult to control the size and the distance between the nanocrystals, even if progresses have been made in these last years.<sup>7,20-22</sup> Theoretically, the impact of NC-NC separation on their optoelectronic properties has been only recently considered.<sup>14,23-25</sup> Allan and Delerue<sup>23</sup> have studied the energy transfer between Si nanocrystals showing that the transfer is possible only when the dots are almost in close contact. Seino *et al.*<sup>25</sup> have studied, using *ab initio* density functional theory (DFT) based methods, the impact of NC size and NC-NC separation on the electronic properties and carrier transport for Si NCs embedded in a SiO<sub>2</sub> matrix. Their main conclusion was that, at small separation (0.2 nm), the energy levels of the NC are broadened to minibands due to wave-function overlap, thus enabling electron transport. In the calculations, they consider

a three-dimensional arrangement of nearly spherical Si NCs in a simple cubic lattice with a single NC per unit cell and the atomic geometry is optimized. The variation in the distance between neighboring NCs is obtained by changing the dimension of the embedding matrix, therefore all the NCs in the calculations are equivalent. A similar approach has been used by Gali *et al.*<sup>24</sup> for H-terminated Si NCs. They consider two different arrangements for the Si NCs in their supercell, a configuration where the distance between neighboring NCs is the same in each direction and another configuration where two neighboring NCs are closer to each other only in one direction. Looking at the results for NC absorption, they concluded that the absorption clearly increases in all energy ranges as the NCs approach each other. Again, Govoni *et al.*<sup>14</sup> have studied energy transfer, charge transfer, and carrier multiplication (CM) effects, adopting a fully *ab initio* scheme within DFT, in both isolated and interacting H-passivated Si-NCs. A side-by-side comparison of the calculated electron- and hole-initiated CM lifetimes, demonstrated the existence of a lifetime hierarchy, thus explaining the impact of NC-NC interaction on CM dynamics. Finally, Lin *et al.*<sup>26</sup> have made use of many-body Green function analysis and first-order perturbation theory to quantify the influence of size, surface reconstruction, and surface treatment on exciton transport between small Si NCs. Their analysis shows that QC causes small (~1 nm) Si NCs to exhibit exciton transport efficiencies far exceeding that of their larger counterparts for the same center-to-center separation. They also find that surface reconstruction significantly influences the absorption cross section and leads to a large reduction in both transport rate and efficiency. The influence of strain on the optoelectronic properties of semiconductor materials has become a hot topic in the last years, especially regarding possible device applications. Regarding bulk Si, the possibility of using strain to induce second harmonic generation, otherwise prohibited for symmetry reasons, has been recently demonstrated through a combined experimental-theoretical effort.<sup>27</sup> As far as nanostructures, the main interest has been on Si, Ge, and SiGe nanowires, where DFT calculations have demonstrated their ability, in perspective, to guide the syntheses of nanowires of controlled shape and geometry for different electronic applications.<sup>28</sup>

In the present work, we focus on the role of strain on the NCs orbital localization, considering both the strain induced by an embedding  $\text{SiO}_2$  matrix and the strain due to the lowering of the distance between the NCs. In our calculations, we consider, in all cases, the presence of two Si NCs in the unit cell, thus we can vary their distance in one direction, while the distance between their periodic images is dictated by the choice of the supercell. We demonstrate that at NC-NC separation lower than a certain threshold, strain-inducing forces mutually acting on the NCs emerge, playing an important role in the global response. This aspect should be worth of consideration when dealing with realistic NC ensembles, as for the case of colloidal Si NCs samples<sup>29,30</sup> as well as for embedded ones.<sup>7,20,36</sup>

### A. Structures and methods

In this work, we consider a pair of Si-NCs with diameter of about 1 nm, the  $\text{Si}_{17}$  and the  $\text{Si}_{32}$  (in  $\text{Si}_N$ ,  $N$  is the number of Si atoms forming the nanocrystal), generated by removing the oxygens from two spherical regions of a  $4 \times 4 \times 4$  betacristobalite- $\text{SiO}_2$  sample formed by 1536 Si/O atoms (see Fig. 1, left panel). After an ionic relaxation, the resulting system is formed by the two NCs embedded in the same  $\text{SiO}_2$  sample and a subject to a strain, especially at the Si/ $\text{SiO}_2$  interface due to the difference in the lattice spacing of Si and  $\text{SiO}_2$ .<sup>31,32</sup> Concerning the NC-NC separation we have considered two different distances  $d$  between the two NCs,  $d = 0.8$  nm and 0.2 nm,  $d$  indicating the minimum distance between the atoms of one NC and that of the neighbor. In order to distinguish the strain induced by the matrix from that induced by the mutual forces between the NCs, we get rid of the  $\text{SiO}_2$  matrix by de-embedding the NCs together with the first shell of interface oxygens (in order to mimic the presence of the  $\text{SiO}_2$ ),<sup>31,32</sup> preserving the strained geometry of the NCs and by hydrogenating all the dangling bonds in order to avoid the presence of electron states in the band gap. The resulting (de-embedded) system is shown in Fig. 1, right panel. For a better understanding of the role of NC-NC interaction with respect to that of the matrix-induced strain, we have also considered the case of two de-embedded NCs placed at a distance of  $d = 0.2$  nm but possessing the original geometry of the two NCs relaxed at  $d = 0.8$  nm.

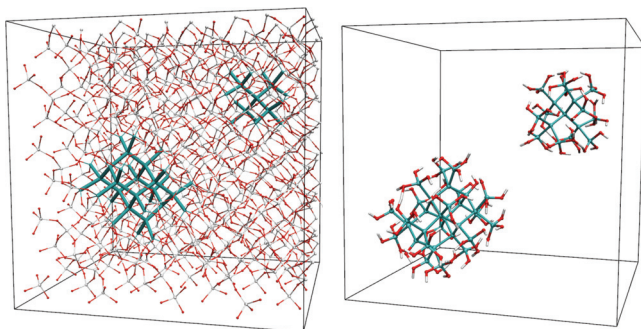


FIG. 1. (Color online)  $\text{Si}_{17} + \text{Si}_{32}$   $\text{SiO}_2$ -embedded (left) and de-embedded (right) NCs pair at a surface-to-surface distance  $d = 0.8$  nm. Si, O, and H atoms are represented in cyan, red, and white, respectively. Si atoms of the  $\text{SiO}_2$  are represented in white for clarity. The simulation box, displayed by black lines, has a side of 2.78 (left) and 2.60 nm (right).

Next, the so-obtained *freestanding* NCs were initially relaxed in separate simulation boxes in order to completely remove the strain (detached relaxation). Then we have considered the case of a rigid placement of the NCs in the same simulation box and the case of a further structural relaxation that comprise the effects of mutual NC-NC interaction forces (conjoined relaxation). This time, the NCs are placed at  $d$  of 0.8, 0.5, and 0.2 nm. All the calculations have been performed for the  $\text{Si}_{32} + \text{Si}_{17}$  and for the  $\text{Si}_{32} + \text{Si}_{32}$  NCs pairs. However, since we have obtained equivalent results for the two cases, for the sake of simplicity we will consider only the first case in the following.

Structural, electronic, and optical properties have been obtained by full *ab initio* calculations in the framework of density functional theory (DFT) using the ESPRESSO package.<sup>33</sup> Calculations were performed using norm-conserving pseudopotentials within the local-density approximation (LDA). An energy cutoff of 60 Ry on the plane-wave basis set was considered after an apposite convergency test. The optical properties were calculated within the random-phase approximation (RPA) using dipole matrix elements.<sup>34</sup> For the freestanding NCs, in all the calculations, we have omitted the vacuum states, i.e., the conduction states of energy equal or above the vacuum energy  $E_{\text{vac}}$ . An estimate of  $E_{\text{vac}}$  can be obtained by properly aligning the eigenvalues after applying the Makov-Payne correction to the total energy.<sup>35</sup> Alternatively, the vacuum states are identifiable by an inverse participation ratio (IPR, see Appendix B) well below a certain threshold. For each system, we have evaluated  $E_{\text{vac}}$  by a crosscheck of both methods.

## II. ELECTRONIC AND OPTICAL RESPONSE

At first, we discuss the results for the two Si NCs embedded in the  $\text{SiO}_2$  matrix. In Ref. 32, we were able to distinguish between the properties that depend only on the NC from those that are instead influenced by the presence of the matrix showing that a single de-embedded NC is able to reproduce very well the absorption spectrum of the full Si/ $\text{SiO}_2$  system in the energy region up to 7 eV, which is indeed associated to the NC + interface contribution. Instead, the removal of the strain (detached NC) produces an enlargement of the HOMO-LUMO gap and a consequent blue shift in the absorption spectra in this region (see Table 1 and Fig. 2 of Ref. 32). These results were confirmed by Kusova *et al.*<sup>36</sup> that have collected a large number of experimental data from various sources to demonstrate that free-standing oxide-passivated silicon nanocrystals exhibit considerably blueshifted emission compared to those prepared as matrix-embedded ones of the same size. This effect arise from compressive strain, exerted on the nanocrystals by the matrix, which plays an important role in the light-emission process.

Here, in Fig. 2, we report our calculated band structures and absorption spectra (represented by the imaginary part of the dielectric function) of the embedded NCs pair placed at  $d$  of 0.2 and 0.8 nm. Concerning the bands, we note that all the states in the shown energy window are strongly confined, presenting no visible dispersion in energy. This result is at variance with the outcome of Seino *et al.*<sup>25</sup> that for a distance between the NCs of  $d = 0.2$  nm, report minibands forming due to the interaction between the NCs. The reason of this

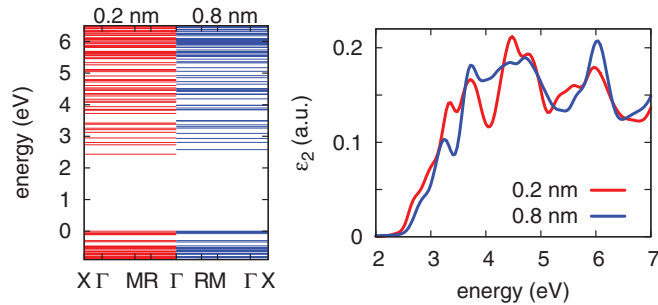


FIG. 2. (Color online) Band structure (left) and the imaginary part of the dielectric function (right) of the  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair embedded in  $\text{SiO}_2$  at  $d = 0.2$  and  $0.8$  nm. In the left panel, the zero energy corresponds to the top of the valence band.

discrepancy is, in our opinion, due to the fact that Seino *et al.*<sup>25</sup> do not consider two NCs embedded in the  $\text{SiO}_2$  matrix at different distances, but used, instead, a reduction of the matrix thickness in order to simulate two NCs placed at short distance. At the end, in their calculation, one is in presence of a large collection of vicinal Si NCs (due to the presence of images of the NCs in the supercell calculation), thus their calculation is more suitable for the discussion of the formation of a quantum dots solid than for elucidating the interaction between single NCs.

Still looking at Fig. 2, we note that the energy gap reduces with the distance, consistently with the limit case of connected NCs (i.e., corresponding to a single large cluster). Regarding the absorption spectrum, we observe a change of the profile with the distance, while the total integrated absorption is preserved. The latter statement may suggest that no two-site ( $\text{NC}_A\text{-NC}_B$ ) optical transitions contribute to the absorption at  $d = 0.2$  nm, or that the new two-site transitions arise to the detriment of the one-site ( $\text{NC}_A\text{-NC}_A$ ) ones. This aspect will be clarified in the following.

In order to discern between the role of NC-NC distance and that of strain, we report in Fig. 3 the absorption spectra

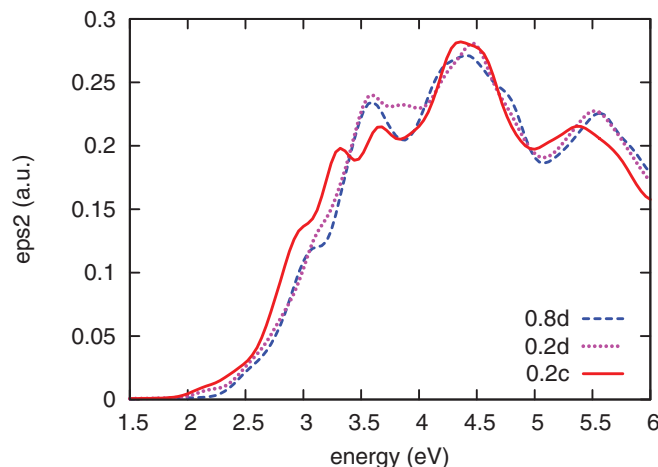


FIG. 3. (Color online) Imaginary part of the dielectric function for the  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair relaxed in the  $\text{SiO}_2$  matrix and then de-embedded. The curves report values for systems relaxed at  $d = 0.8$  nm (0.8d), relaxed at  $d = 0.8$  nm, and then rigidly placed at  $d = 0.2$  nm (0.2d), and relaxed at  $d = 0.2$  nm (0.2c).

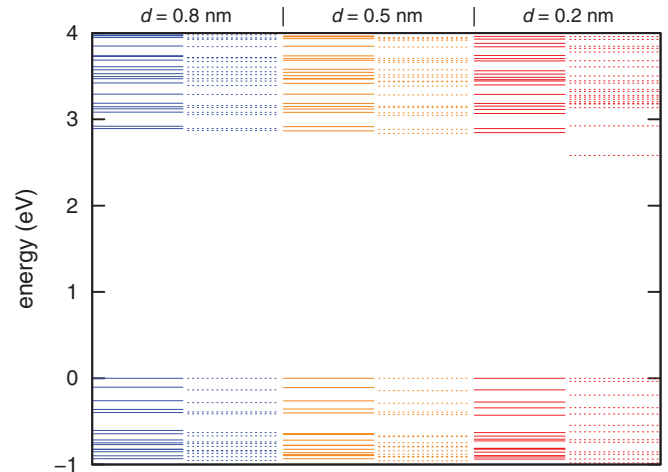


FIG. 4. (Color online) Valence and conduction band-edge energy levels of the  $\text{Si}_{32} + \text{Si}_{17}$  freestanding NCs placed at distance  $d = 0.8$  (blue),  $0.5$  (orange), and  $0.2$  nm (red), for detachedly (solid lines) or conjointly (dotted lines) relaxed structures. The HOMO level marks the zero of energy.

of the NCs pair de-embedded from the  $\text{SiO}_2$  matrix, to be compared with those of Fig. 2, right panel. As expected,<sup>31,32</sup> we note a clear resemblance of the spectra with their embedded counterparts. In addition, the embedded NCs pair relaxed at  $d = 0.8$  nm has been de-embedded and rigidly placed at  $d = 0.2$  nm, producing a spectrum (dotted curve) very similar to that of the same pair placed at  $d = 0.8$  nm (dashed curve). The latter result indicates that the strong strain of embedded NCs plays a fundamental role on the final absorption, ruling over the sole variation of  $d$  for closely neighboring NCs.

Next, we compare the energy levels of the  $\text{Si}_{32} + \text{Si}_{17}$  freestanding NCs pair, detachedly or conjointly relaxed, as a function of  $d$  (see Fig. 4). First of all, we note, as expected for the detachedly relaxed structures, an enlargement of the gap with respect to the embedded and de-embedded cases, due to the strain relaxation; second, we note that at  $d = 0.5$  and  $0.8$  nm, the effect of the mutual NC-NC forces is negligible, producing small variations of the energy levels for the conjointly relaxed structures. Furthermore, at all  $d$ , a very weak variation of the energy levels is observed for the rigidly placed (detached) structures, in agreement with other works.<sup>24</sup> Instead, at  $d = 0.2$  nm, we observe a reduction of the HOMO-LUMO band gap of about 10% when the structures are let free to move. This result clearly indicates a relevant influence of the structural rearrangement induced by the mutual forces over the electronic configuration of the NCs. In this case, the reduction of the gap may be addressed to the strain induced by the mutual NC-NC interaction forces. It is interesting to note that  $d = 0.2$  nm is also the separation at which the energy levels of the NCs broaden to minibands for Si NCs embedded in a  $\text{SiO}_2$  matrix,<sup>25</sup> making this range of NC-NC distances a particular interesting one.

In order to investigate the effect of the structural relaxation on the optical properties of NC ensembles, we report in Fig. 5(a) the absorption spectra corresponding to the band structures depicted in Fig. 4. From Fig. 5(a), we observe that for detachedly relaxed structures there are only small changes

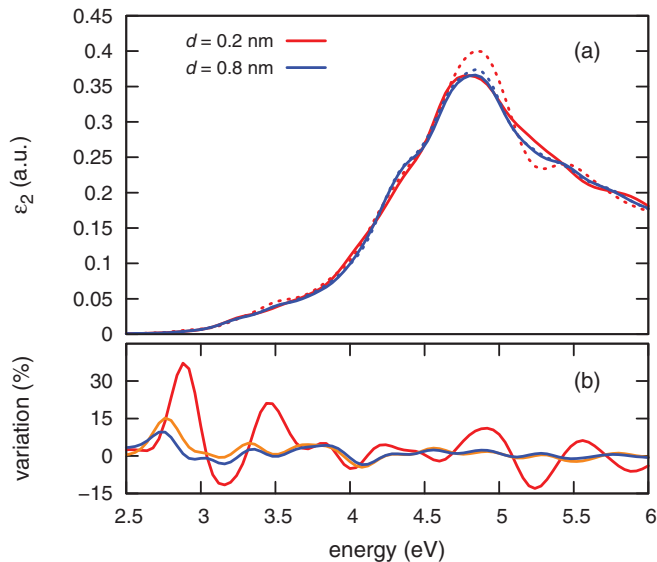


FIG. 5. (Color online) (a) Imaginary part of the dielectric function for the  $\text{Si}_{32} + \text{Si}_{17}$  freestanding NCs pair detachedly (solid lines) or conjointly (dotted lines) relaxed in vacuum at distances  $d = 0.8$  nm (blue) and  $d = 0.2$  nm (red). (b) The relative variation between  $\epsilon_2$  of detachedly and conjointly relaxed structures at the same distances and at  $d = 0.5$  nm (orange).

in the spectra, whereas a significant variation of the absorption spectrum due to the structural relaxation is visible on going from  $d = 0.8$  to  $0.2$  nm. This variation can go up to 37% as showed in Fig. 5(b). From the same figure we note that the structural rearrangements show only a minor effect at  $d = 0.5$  nm, making clear that such mechanism is especially relevant in densely packed NC ensembles. Besides, we expect that the threshold  $d$  value will depend on the NC size, shape, and passivation type, and cannot therefore hold in general. For example, as showed before, in the presence of an embedding matrix, the possibility of NC's structural rearrangement as a consequence of their decreasing distance is much limited. This latter aspect will be further discussed in the following.

Still from Fig. 5(a) we note that the variation of  $d$  and the structural rearrangement connected to it have some role on the NCs pair absorption. It is, therefore, interesting to compare the effect on the total absorption of the pure variation of the distance (fixed structures) with that of the pure relaxation of the structures (fixed distance). By looking at Fig. 6 we observe that, for freestanding NCs, the relaxation clearly dominates over the total change of the absorption. This outcome allots to the structural strain a fundamental role in high-dense NC ensembles and suggests the possibility of tuning the absorption characteristics by a controlled strain in light-driven applications, like, for example, photovoltaic cells or optical catalyzers. The possibility of performing strain relaxation in Si/SiO<sub>2</sub> NCs has been recently demonstrated by Arguirov *et al.*<sup>37</sup> using local laser annealing.

#### A. Orbital localization and interaction

Since in our system (made by two NCs) the absorption can be interpreted in terms of contributions from one-site and two-site interband transitions (valence state to conduction state),

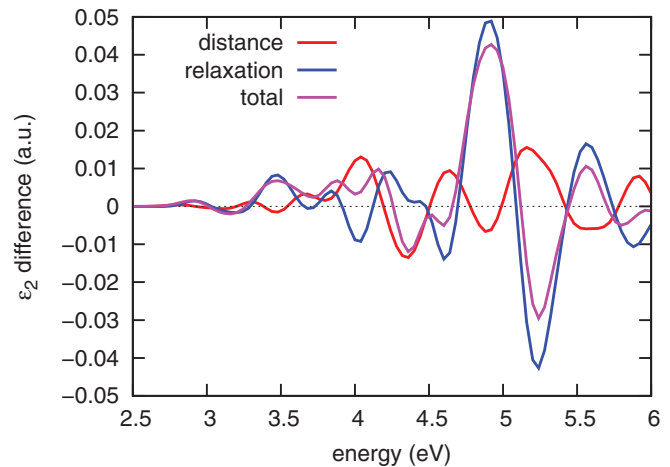


FIG. 6. (Color online)  $\epsilon_2$  variation for the freestanding  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair in case of rigid displacement from  $d = 0.8$  to  $0.2$  nm with NC geometry detachedly relaxed (red line), of the sole conjoint relaxation at  $d = 0.2$  nm starting from the detachedly relaxed geometry (blue line), and the sum of the two (purple line).

it is not clear at this stage whether the modification of the absorption profile is governed by the former or by the latter transition type. In order to inquire into this aspect, we have compared the optical transition rate (see Appendix A) of the one-site and two-site interband transitions of smallest energy. The characteristics of the transition, one or two sites, have been revealed by a plot of the involved orbitals.

In Fig. 7(b), we report the  $\text{HOMO}_A\text{-LUMO}_B$  ( $A = \text{Si}_{32}$  and  $B = \text{Si}_{17}$ ) transition rate  $R$  as a function of  $d$  and of the structural configuration. As expected, for freestanding detached and conjoined NCs, the one-site  $R$  (upper panel) are stronger than the two sites ones for all the considered  $d$ . Moreover, for the detachedly or conjointly relaxed systems

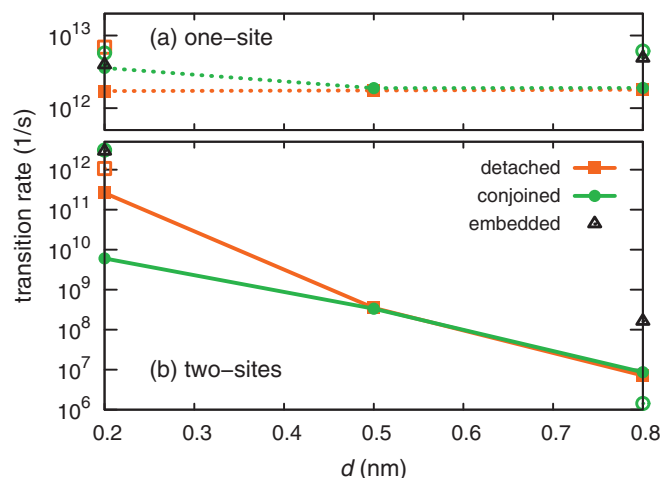


FIG. 7. (Color online) Optical transition rate for ( $A = \text{Si}_{32}$ ,  $B = \text{Si}_{17}$ ): two-site  $\text{HOMO}_A\text{-LUMO}_B$  transition (bottom) and one-site  $\text{HOMO}_A\text{-LUMO}_A$  transition (top) as a function of the separation  $d$ . Squares and circles indicate values for detachedly and conjointly relaxed NC-NCs pairs, respectively. Filled and empty marks indicate freestanding and de-embedded NCs, respectively. Data for the embedded NCs are also reported by triangles. Lines are drawn to guide the eye.

we observe a matching of the  $R$  values at  $d = 0.8$  and  $0.5$  nm both for one-site and two-site transitions. Instead, at  $d = 0.2$  nm, a drastic reduction of  $R$  (of a factor 50) appears in the case of conjoined relaxation for the  $\text{HOMO}_A$ - $\text{LUMO}_B$  two-site transition, while the one-site  $\text{HOMO}_A$ - $\text{LUMO}_A$  transition is enhanced by a factor of about two. This result suggests that the two-site  $\text{HOMO}_A$ - $\text{LUMO}_B$  transitions are much more sensitive to the strain-induced variations of the wave-function extent with respect to the one-site  $\text{HOMO}_A$ - $\text{LUMO}_A$ . In fact, two-site transitions require orbitals overlapping in the interstitial region between the NCs; in this picture and following the above result, the overlap increases at smaller  $d$  due to orbital approaching but decreases when the NCs are subjected to the strain. On the contrary, since the one-site  $R$  depends on the overlap of orbitals localized on the same NC, it slightly decreases when the structures are rigidly approached (due to delocalization), while its increase during a conjoint relaxation indicates a relocalization of the orbitals. Therefore the total  $R$  is explainable by a decrease of the orbital extent outside the NCs, enhancing the one-site oscillator strength to the detriment of the two-site one. This result seems to suggest that for freestanding small Si NCs, the structural rearrangement arising from NC-NC interaction at low  $d$  tends to force the HOMO-LUMO delocalized states back into the NCs. In practice, the two-site orbital overlap produces repulsive forces that screen the overlap itself.

The presence of negative values in Fig. 5(b) reveals that the effect of the strain over the states localization is not common to all the orbitals but is energy dependent. As a consequence, the discussion above holds for interband transitions at energies approaching the band gap, but no generalization can be applied at this stage.

The case of embedded NCs is more complex and needs some additional arguments. In this case, we expect that beside inducing a severe strain on the NCs, the presence of a hosting matrix also limits the mobility of the system, reducing the possibility of structural rearrangements at low  $d$ . In addition, while at large  $d$  the  $\text{SiO}_2$  surrounding the NCs is able to partially compensate the stress emerging at the NCs interface, at small  $d$  the few  $\text{SiO}_2$  atoms in the interstitial NC-NC region cannot compensate the stress anymore, which, in this case, is maximized and shared between the NCs. Therefore the structural modifications at the origin of the modifications of the absorption profile of Fig. 3 may not be produced by the NC-NC interaction forces, like in the freestanding case, but by the increase of the  $\text{SiO}_2$ -induced strain for the reason discussed above. The latter picture finds support in Fig. 7 (see empty marks), where the  $R$  at  $d = 0.2$  nm of the de-embedded NCs shows a poor dependence on the relaxation type. In this case, the trend of the one-site  $R$  appears even inverted, indicating that the  $\text{SiO}_2$ -induced strain completely rules over the NC-NC mutual interaction forces and supporting the idea of a very limited capability of structural relaxations of the embedded NCs as a function of the NC-NC separation.

In the case of embedded NCs, we observe increased  $R$  with respect to the freestanding counterparts. Also, the  $R$  of de-embedded NCs match those of embedded ones, with the only exception of the two-site  $R$  at  $d = 0.8$  nm that may be addressable to the different dielectric constants of  $\text{SiO}_2$  and vacuum.

The severe strain induced by the embedding matrix seems to promote a delocalization of the involved orbitals, since the two-site  $R$  is favoured at each  $d$ , while the one-site one seems to reduce at decreasing  $d$ . Moreover, it is interesting to note that the delocalization is so strong in this case that at  $d = 0.2$  nm, the two-site  $R$  approaches the value of the one-site one. Following this picture, we expect a strain-dependent NC-NC separation threshold for the formation of minibands in closely-packed NC arrays.<sup>25</sup>

The reduced possibility of embedded NCs to “screen” the presence of a neighbor NC renders the embedded systems an ideal candidate for applications that require strong energy/charge transfer between neighboring NCs. At the opposite, in the case of freestanding, colloidal NC samples, we expect a reduced NC-NC interplay (due to localized states). We want to stress out that following the superposition principle, in the limit case of noninteracting NCs, the response of the ensemble shall be describable by the mere sum of the individual NC responses. Since in photoluminescence (PL) experiments the photogenerated exciton thermally decays toward the band edge before radiative recombination,<sup>38</sup> we suggest that the strain-induced variation of  $R$  described above may be observable in PL experiments of colloidal samples by varying the NCs density.

## B. Interband optical transitions

As anticipated above, the variation of the absorption with the strain is not constant but depends on the energy or, more specifically, on the initial and final transition states. To shed light on this point, we must distinguish the optical transitions whose sum forms the absorption spectrum. To quantify the orbital localization, we make use of the inverse participation ratio (IPR), a numerical value connected to the ratio between the simulation box and the orbital volumes (see Appendix B). To higher IPRs correspond higher orbital localizations and vice versa.

In Fig. 8, we report the IPRs for the  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair placed at  $d = 0.2$  nm as a function of the orbital energy and of

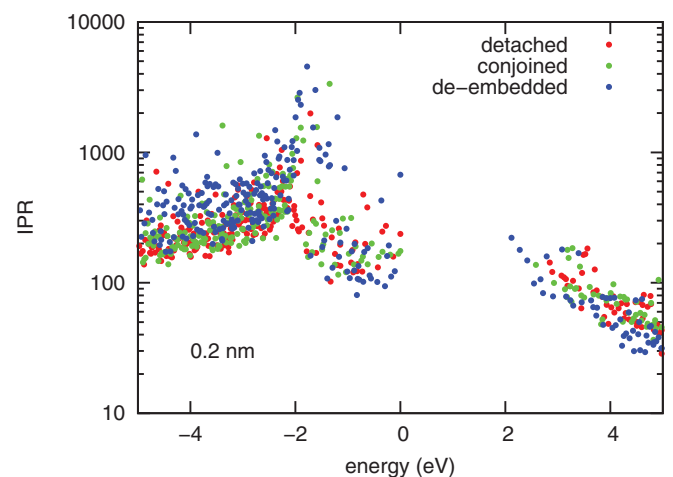


FIG. 8. (Color online) IPR values for the freestanding  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair placed at  $d = 0.2$  nm as a function of the orbital energy and of the relaxation type. The zero of energy corresponds to the HOMO levels.

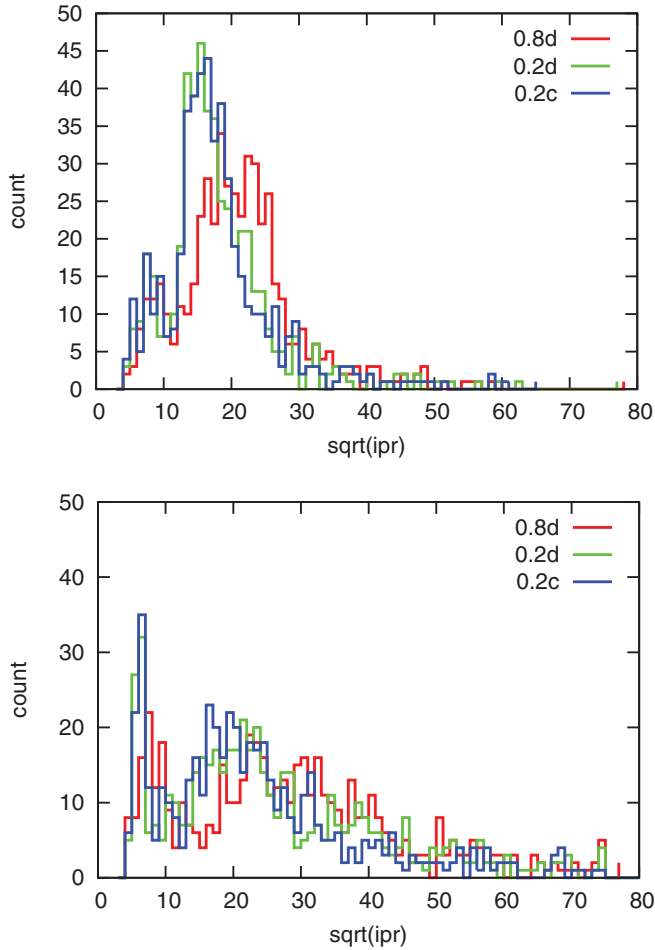


FIG. 9. (Color online) Distribution of the IPR values for the freestanding (top) or de-embedded (bottom)  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair. The curves report values for systems relaxed at  $d = 0.8$  nm (0.8d), relaxed at  $d = 0.8$  nm, and then rigidly placed at  $d = 0.2$  nm (0.2d), and conjointly relaxed at  $d = 0.2$  nm (0.2c).

the relaxation type. Clearly, to a higher strain (de-embedded versus conjoint versus detached) corresponds an increased spread between states with high and low IPRs: the IPR of deep valence states ( $E \lesssim -1.5$  eV) gets increased with the strain, while it is decreased for shallow valence and conduction states ( $E \gtrsim -1.5$  eV). The mutual NC-NC forces modify the NCs configuration during the conjoint relaxation, leading to an increased strain. However, the effect of the mutual NC-NC interaction is less pronounced with respect to that of an embedding  $\text{SiO}_2$  matrix. The authenticity of the latter statement appears more clearly by comparing the IPR distribution of the NCs pair relaxed in vacuum (detached) with that relaxed in  $\text{SiO}_2$  (de-embedded), as reported in Fig. 9. Clearly, independent of the NC-NC distance, in the latter case, the low-IPRs peak ( $\sqrt{\text{IPR}} \lesssim 12$ ) increases by a factor of about two, the high-IPRs peak ( $12 \lesssim \sqrt{\text{IPR}} \lesssim 30$ ) is reduced by about the same factor, while the number of very-high IPRs ( $\sqrt{\text{IPR}} \gtrsim 30$ ) slightly increase. Therefore the overall effect of the strain on the IPRs appears as a broadening of the IPR distribution together with a boost of the low-IPRs peak and a damping of the high-IPRs one. Comparing the 0.8d and 0.2d curves of Fig. 9, we also observe that for a fixed

NCs geometry, the sole reduction of the NC-NC distance entails a delocalization of the orbitals (red versus green curves).

As discussed above, the variation of the orbital localization with the distance/strain directly impacts the transition rate due to the connection between the matrix element and the initial-final states overlap (see Appendix A). In Fig. 10, we report the transition rate versus transition energy of the  $\text{Si}_{32} + \text{Si}_{17}$  NCs pair relaxed in vacuum (left panels) or in a  $\text{SiO}_2$  matrix (de-embedded, right panels) at  $d = 0.8$  and  $0.2$  nm with different relaxation types. In the same figure, the IPR of the orbitals associated with each transition rate is indicated by the color/size of the data points. At first, we observe that at  $d = 0.8$  nm, the transition rates involving two states localized on different NCs (two-site transitions, identifiable by a comparison with calculations for single NCs) are dramatically unfavored and clearly separated by the one-site ones, especially at low energy. At higher energies, the highly-delocalized valence orbitals come into play, forming a band of intermediate rates. Instead, the extremely localized orbitals (deep states) produce high (one-site) or very-low (two-site) rates because of the impossibility of overlapping in the interstitial region between the NCs.

We note that the transitions with the highest rate have energies around 4.5 eV for the system relaxed in vacuum, and around 3.5 eV for the system relaxed in  $\text{SiO}_2$ . However, these energies do not correspond to the  $\varepsilon_2$  maximum since the latter depends not only on the strength of the transitions but also on their number [see Eq. (A5) of Appendix A]. Since the maximum achievable rate does not depend on  $d$ , it evidently pertains to one-site transitions. Besides, when the NCs are rigidly placed at  $d = 0.2$  nm (see Fig. 10, central panels) we observe that the two-site  $R$  approach the one-site ones, while a general orbital delocalization appears, consistently with Fig. 9. After the conjoint relaxation at  $d = 0.2$  nm (see Fig. 10, bottom panels), the re-localization of the deep valence states (that are involved in high-energy transitions) is evidenced by an increased number of yellow dots in the figure.

Consistently with Fig. 7, in the case of freestanding NCs, the conjoint relaxation boosts the one-site  $R$  while reducing the two-site ones. Instead, as discussed above (see Fig. 9), in the case of de-embedded NCs, the high  $\text{SiO}_2$ -driven strain forms a large number of extremely localized states in a background of very delocalized states. The large strain makes difficult to recognize changes of  $R$  driven by the NC-NC interaction forces.

Finally, we note that, since the strain can either increase or reduce the IPR depending on the orbital energy, such dependency on the energy is reflected on the transition rates and finally on the  $\varepsilon_2$ . Therefore the applied strain produces higher or lower rates depending on the energy of the initial and final state of the transition. The above considerations explain the alternating variation of the absorption shown in Fig. 5(b).

### C. Intraband optical transitions

While interband transitions are essentially related to optical absorption/emission, intraband transitions plays a fundamental

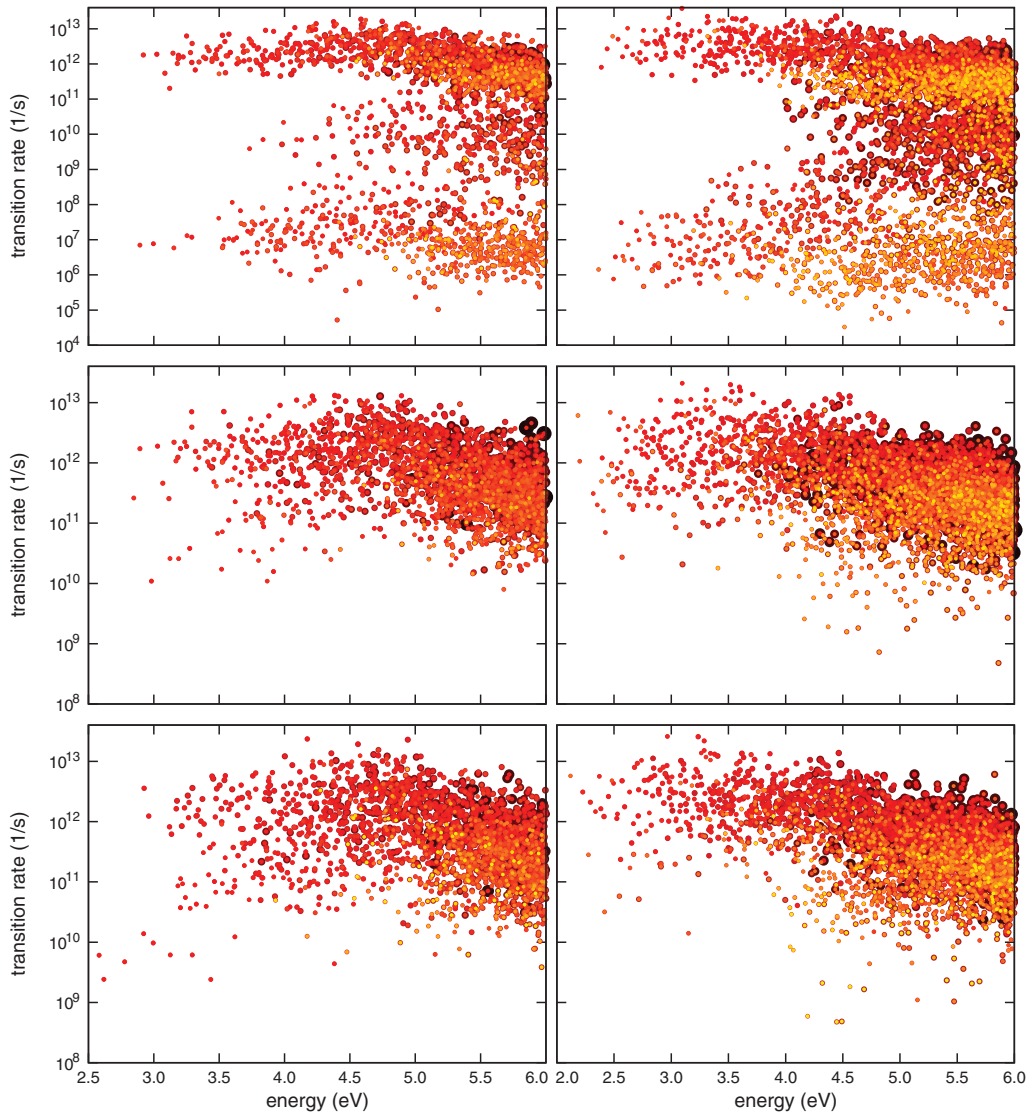


FIG. 10. (Color online) Interband transition rates for the freestanding  $\text{Si}_{32} + \text{Si}_{17}$  pair relaxed in vacuum (left panels) or in a  $\text{SiO}_2$  matrix (de-embedded, right panels). (Top) Data for NCs relaxed at  $d = 0.8$  nm, (middle) values for NCs relaxed at  $d = 0.8$  nm and then rigidly placed at  $d = 0.2$  nm, and (bottom) values for NCs relaxed at  $d = 0.2$  nm. The IPR of the orbitals involved in each transition are indicated by the color/size of the dots. Dark/large, red/medium, and yellow/small dots indicate states with IPR below, near to, and above the threshold value of 144 (see also Fig. 9). For the sake of comparison the color/size scale of the dots is fixed for all the plots.

role in processes such as SSQC,<sup>12–14</sup> MEG,<sup>14,39</sup> transport,<sup>40</sup> and others. The possibility of controlling the rate of the above processes in dense NC ensembles has attracted a lot of interest in the latest years.<sup>14</sup> Besides, the role of strain on the above mechanisms has been often neglected. It is, therefore, important to understand how the above results apply in the case of intraband transitions.

Intraband transitions can be performed by electrons transiting on the conduction band, or by holes transiting on the valence band. Since strain has opposite effects on orbitals belonging to deep valence and shallow valence and conduction band, we expect an asymmetric effect on the transition rates of electron and holes.

As shown in Fig. 8, in the case of conduction states, the strain uniformly delocalizes the orbitals, favoring the

coupling between states belonging to different NCs. Therefore we expect in this case an enhanced possibility of energy or electron transfer between neighboring NCs at higher strain levels.

In the case of valence states, one has to distinguish between shallow and deep states. Since IPR changes are opposite for shallow and deep valence states, we expect a large effect of the strain on the transition rates.

The scenario outlined above emerges in Fig. 11 in which the intraband transition rates for electrons (positive energies) and for holes (negative energies) are presented for systems subject to different strain levels. Clearly, transitions in the valence band are dramatically interfered by the strain, while transitions in the conduction band are unaltered or possibly favored, especially at high energy. This result may explain the dominance of

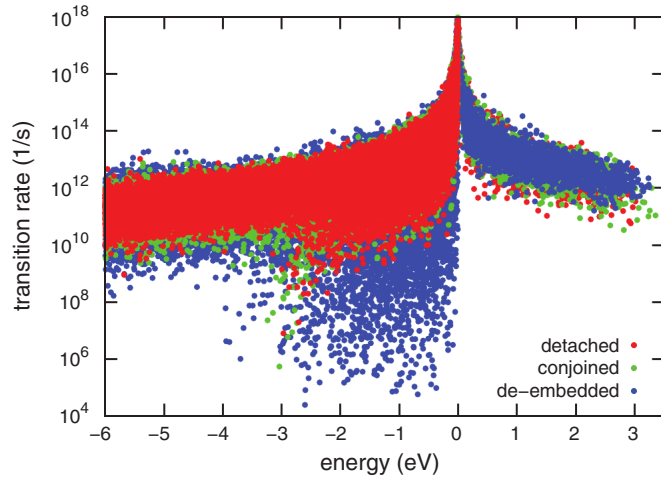


FIG. 11. (Color online) Intraband transition rates for the  $\text{Si}_{132} + \text{Si}_{17}$  NCs pair relaxed in vacuum at  $d = 0.8$  nm and then rigidly placed at  $d = 0.2$  nm (detached), conjointly relaxed at  $d = 0.2$  nm (conjoined), and relaxed in  $\text{SiO}_2$  at  $0.8$  nm and then de-embedded and rigidly placed at  $d = 0.2$  nm (de-embedded). Positive and negative energies refer to transitions in the conduction and valence bands, respectively.

electron transport over hole transport in  $\text{Si}/\text{SiO}_2$  embedded NCs,<sup>25</sup> and strongly fosters the employment of strained structures in future experiments<sup>36</sup> to verify the possibility of enhancing or reducing the NC-NC interaction mechanisms in samples with high NCs density.

### III. CONCLUSIONS

In dense NC ensembles, the overlap of the wave functions of two neighboring NCs produces a reconfiguration of the electronic structure of the NCs, and a structural rearrangement following the mutual NC-NC interaction forces. In agreement with other works,<sup>12–14,24,25</sup> our results indicate that a close packing of Si-NCs is required in order to evidence any kind of interaction effect. For our systems, we have measured a threshold surface-to-surface NC-NC distance of about 0.5 nm, below which we observe some kind of electronic and ionic structural reconfiguration.

By relaxing the NCs in vacuum or in a  $\text{SiO}_2$  matrix and by rigidly placing the NCs in the simulation box or by permitting a full conjoint relaxation of the NCs pair including the mutual NC-NC interaction forces, we have been able to distinguish the effect of the NC-NC distance by that of the strain on the optical and electronic properties of the system.

At first, we have observed that the sole reduction of  $d$  produces a general increase of the orbitals extent, promoting the rate of two-site transitions. Besides, the sole increase of the strain acts differently on conduction, on shallow valence, and on deep valence states. While the former two get delocalized, the latter increase their localization, producing a complex response that strongly depends on the transition energy.

In the case of optical absorption (i.e., interband transitions), we have shown that for freestanding NCs the structural rearrangement induced by the mutual NC-NC interaction forces dominates the spectral modifications with respect to the

sole variation of the distance. In the presence of an embedding matrix, the effect of the mutual NC-NC interaction forces is reduced, while large matrix-induced strain maximizes the orbital localization/delocalization effect.

In the case of intraband transitions, we have shown that transitions within the conduction band are promoted by higher strain levels, while transitions within the valence band are strongly limited. The latter result may explain the dominance of electrons over holes in the transport properties of  $\text{SiO}_2$ -embedded Si NCs.<sup>25</sup>

In general, our results reveal that for neighboring NCs, the strain may have a great influence over any kind of NC-NC interaction mechanisms, suggesting the possibility of a strain-enabled and process-dependent control of the response in colloidal<sup>30</sup> or embedded<sup>37</sup> Si-NC ensembles.

### ACKNOWLEDGMENTS

Computational resources were made available by CINECA-ISCRA parallel computing initiative. We acknowledge financial support from the European Community's Seventh Framework Programme (FP7/2007-2013) under Grant No. 245977.

### APPENDIX A: TRANSITION RATE

The rate of absorption or emission processes of radiation with energy  $\hbar\omega$ , intensity  $A_0$ , and wave vector  $\mathbf{q}$ , is defined from the Fermi golden rule and is given by<sup>41</sup>

$$W(\mathbf{q}, \omega) = \frac{2\pi}{\hbar} 2 \sum_{i,j} |\langle j|A_0 e^{i\mathbf{q}\cdot\mathbf{r}}|i\rangle|^2 \delta(E_{ij} - \hbar\omega)(f_i - f_j), \quad (\text{A1})$$

where  $E_{ij} = E_i - E_j$ ,  $f_i$  and  $f_j$  are the occupations of states  $|i\rangle$  and  $|j\rangle$ , and the factor 2 in front of the summation takes into account the spin degeneracy. In the case of absorption, the sum is performed over valence states  $|i\rangle$  with  $f_i = 1$ , and conduction states  $|j\rangle$  with  $f_j = 0$ , with  $E_{ij} > 0$ . The imaginary part of the dielectric function,  $\varepsilon_2$  is related to  $W$  by

$$\varepsilon_2(\mathbf{q}, \omega) = \frac{2\pi\hbar e^2}{q^2} \frac{1}{V} \frac{W(\mathbf{q}, \omega)}{|A_0|^2}, \quad (\text{A2})$$

where  $e$  is the electron charge and  $V$  is the cell volume. In the long-wavelength limit, we have

$$\langle j|e^{i\mathbf{q}\cdot\mathbf{r}}|i\rangle = i\mathbf{q}\langle j|\mathbf{r}|i\rangle = \frac{\hbar}{m} \frac{i\mathbf{q} \cdot \langle j|\mathbf{p}|i\rangle}{E_{ij}}, \quad (\text{A3})$$

$m$  being the rest mass of electron and  $\mathbf{p}$  the momentum operator. From Eqs. (A1)–(A3), we can express the contribution to  $\varepsilon_2$  of each interband transition  $i \rightarrow j$ , simply referred here as the *transition rate*

$$R_{ij} = \frac{8\pi^2 e^2 \hbar^2}{m^2 V} \frac{|\langle j|\mathbf{p}|i\rangle|^2}{E_{ij}^2}. \quad (\text{A4})$$

Then,  $\varepsilon_2$  is related to  $R$  by

$$\varepsilon_2(\omega) = \sum_{i,j} R_{ij} \delta(E_{ij} - \hbar\omega). \quad (\text{A5})$$



Note that  $R$  and  $\varepsilon_2$  depend on the cell volume  $V$ . For all the calculations, we have used a cubic simulation box with side 2.6 nm, giving  $V = 17.58 \text{ nm}^3$ .

## APPENDIX B: INVERSE PARTICIPATION RATIO

For a given wave function  $\psi_n$  the inverse participation ratio (IPR) is defined as

$$\text{IPR}(\psi_n) = V \frac{\int_V |\psi_n(\vec{r})|^4}{\left[\int_V |\psi_n(\vec{r})|^2\right]^2}, \quad (\text{B1})$$

where  $V$  is the volume of the simulation box. Equation (B1) returns unity for a maximally dispersed state and infinity for a maximally localized state. In numerical simulations, the cell

is divided into a finite grid, and Eq. (B1) reduces to

$$\text{IPR}(\psi_n) = N \frac{\sum_{i=1}^N |\psi_n(\vec{r}_i)|^4}{\left[\sum_{i=1}^N |\psi_n(\vec{r}_i)|^2\right]^2}, \quad (\text{B2})$$

where the sum is performed over the  $N$  volume elements of the grid. Thus the IPR is limited to  $N$  in the case of a maximally localized state. Simply speaking, the IPR is connected to the ratio between the cell volume and the orbital volume. As a reference, Eq. (B2) applied on an hypothetical orbital homogeneously occupying a volume of a sphere with diameter of 1 nm in our calculations would return  $\text{IPR} \simeq 33$ . Instead, the same orbital distributed Gaussianly with a full width at tenth maximum of 1 nm would have  $\text{IPR} \simeq 40$ . In all our calculations, we have used a  $253 \times 253 \times 253$  uniform volume grid in the real space, giving  $N = 253^3$ .

- 
- <sup>1</sup>L. Pavesi, L. Dal Negro, C. Mazzoleni, G. Franzò, and F. Priolo, *Nature (London)* **408**, 440 (2000).
- <sup>2</sup>G. I. Bourianoff and H. A. Atwater, *Nat. Mater.* **4**, 143 (2005).
- <sup>3</sup>S. Tiwari, F. Rana, H. Hanafi, A. Hartstein, E. F. Crabbe, and K. Chan, *Appl. Phys. Lett.* **68** 1377 (1996).
- <sup>4</sup>J. Yao, Z. Sun, L. Zhong, D. Natelson, and J. M. Tour, *Nano Lett.* **10**, 4105 (2010).
- <sup>5</sup>F. Erogbogbo, K-T. Yong, I. Roy, R. Hu, W-C. Law, W. Zhao, H. Ding, F. Wu, R. Kumar, M. T. Swihart, and P. N. Prasad, *ACS Nano* **5**, 413 (2011).
- <sup>6</sup>S. Ossicini, M. Amato, R. Guerra, M. Palumbo, and O. Pulci, *Nanoscale Res. Lett.* **5**, 1637 (2010).
- <sup>7</sup>J. Heitmann, F. Müller, L. Yi, M. Zacharias, D. Kovalev, and F. Eichhorn, *Phys. Rev. B* **69**, 195309 (2004).
- <sup>8</sup>J. Linnros, N. Lalic, A. Galeckas, V. Grivickas, *J. Appl. Phys.* **86**, 6128 (1999).
- <sup>9</sup>M. Glover and A. Meldrum, *Opt. Mater.* **27**, 977 (2005).
- <sup>10</sup>T. Shimitsu-Iwayama, T. Hama, D. E. Hole, and I. W. Boyd, *Solid-State Electron.* **45**, 1487 (2001).
- <sup>11</sup>M. Schneibner, M. Yakes, A. S. Bracker, I. V. Ponomarev, M. F. Doty, C. S. Hellberg, L. J. Whitman, T. L. Reinecke, and D. Gammon, *Nat. Phys.* **4**, 291 (2008).
- <sup>12</sup>D. Timmerman, I. Izeddin, P. Stallinga, I. N. Yassievich, and T. Gregorkiewicz, *Nat. Photon.* **2**, 105 (2008).
- <sup>13</sup>M. T. Trinh, R. Limpens, W. D. A. M. de Boer, J. M. Schins, L. D. A. Siebbeles, and T. Gregorkiewicz, *Nat. Photon.* **6**, 316 (2012).
- <sup>14</sup>M. Govoni, I. Marri, and S. Ossicini, *Nat. Photon.* **6**, 672 (2012).
- <sup>15</sup>S. Ossicini, L. Pavesi, and F. Priolo, *Light Emitting Silicon for Microphotonics*, Springer Tracts on Modern Physics 194 (Springer-Verlag, Berlin, 2003).
- <sup>16</sup>E. Degoli and S. Ossicini, *Adv. Quantum Chem.* **58**, 203 (2009).
- <sup>17</sup>R. Guerra, M. Ippolito, S. Meloni, and S. Ossicini, *Appl. Phys. Lett.* **100**, 181095 (2012).
- <sup>18</sup>L. Dal Negro, J. H. Yi, L. C. Kimerling, S. Hamel, A. Williamson, and G. Galli, *Appl. Phys. Lett.* **88**, 183103 (2006).
- <sup>19</sup>P. Löper, R. Müller, D. Hiller, T. Barthel, E. malguth, S. Janz, J. C. Goldschmidt, M. Hermle, and M. Zacharias, *Phys. Rev. B* **84**, 195317 (2011).
- <sup>20</sup>M. Zacharias, J. Heitmann, R. Scholz, U. Kahler, M. Schmidt, and J. Bläsing, *Appl. Phys. Lett.* **80**, 661 (2002).
- <sup>21</sup>R. Lockwood, A. Hryciw, and A. Meldrum, *Appl. Phys. Lett.* **89**, 263112 (2006).
- <sup>22</sup>S. Godefroo, M. Hayne, M. Jivanescu, A. Stesmans, M. Zacharias, O. I. Lebedev, G. Van Tendeloo, and V. V. Moshchalkov, *Nat. Nanotechnology* **3**, 174 (2008).
- <sup>23</sup>G. Allan and C. Delerue, *Phys. Rev. B* **75**, 195311 (2007).
- <sup>24</sup>A. Gali, M. Vörös, D. Rocca, G. T. Zimanyi, and G. Galli, *Nano Lett.* **9**, 3780 (2009).
- <sup>25</sup>K. Seino, F. Bechstedt, and P. Kroll, *Phys. Rev. B* **86**, 075312 (2012).
- <sup>26</sup>Z. Lin, H. Li, A. Franceschetti, and M. T. Lusk, *ACS Nano* **6**, 4029 (2012).
- <sup>27</sup>M. Cazzanelli, F. Bianco, E. Borga, G. Pucker, M. Ghulinyan, E. Degoli, E. Luppi, V. Véniard, S. Ossicini, D. Modotto, S. Wabnitz, R. Pierobon, and L. Pavesi, *Nat. Mater.* **11**, 148 (2012).
- <sup>28</sup>A. Nduwimana and X-Q. Wang, *J. Phys. Chem. C* **114**, 9702 (2010).
- <sup>29</sup>M. C. Beard, K. P. Knutsen, P. Yu, J. M. Luther, Q. Song, W. K. Metzger, R. J. Ellingson, and A. J. Nozik, *Nano Lett.* **7**, 2506 (2007).
- <sup>30</sup>H. Sugimoto, M. Fujii, K. Imakita, S. Hayashi, and K. Akamatsu, *J. Phys. Chem. C* **116**, 17969 (2012).
- <sup>31</sup>R. Guerra, I. Marri, R. Magri, L. Martin-Samos, O. Pulci, E. Degoli, and S. Ossicini, *Phys. Rev. B* **79**, 155320 (2009).
- <sup>32</sup>R. Guerra, E. Degoli, and S. Ossicini, *Phys. Rev. B* **80**, 155332 (2009).
- <sup>33</sup>P. Giannozzi *et al.*, *J. Phys.: Condens. Matter* **21**, 395502 (2009).
- <sup>34</sup>G. Onida, L. Reining, and A. Rubio, *Rev. Mod. Phys.* **74**, 601 (2002).
- <sup>35</sup>G. Makov and M. C. Payne, *Phys. Rev. B* **51**, 4014 (1995).
- <sup>36</sup>K. Kůsová, L. Ondič, E. Klimešová, K. Herynková, I. Pelant, S. Daniš, J. Valenta, M. Gallart, M. Ziegler, B. Hönerlage, and P. Gilliot, *Appl. Phys. Lett.* **101**, 143101 (2012).
- <sup>37</sup>T. Arguirov, T. Mchedlidze, M. Kittler, R. Rölver, B. Berghoff, M. Först, and B. Spangenberg, *Appl. Phys. Lett.* **89**, 053111 (2006).
- <sup>38</sup>R. Guerra and S. Ossicini, *Phys. Rev. B* **81**, 245307 (2010).
- <sup>39</sup>D. Timmerman, J. Valenta, k. Dohnalova, W. D. A. M. de Boer, and T. Gregorkiewicz, *Nat. Nanotechnology* **6**, 710 (2011).
- <sup>40</sup>I. Balberg, E. Savir, J. Jedrzejewski, A. G. Nassiopoulou, and S. Gardelis, *Phys. Rev. B* **75**, 235329 (2007).
- <sup>41</sup>G. Grosso and G. P. Parravicini, in *Solid State Physics* (Academic Press, 2003).